



# qmb: QSTEM Model Builder



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### Motivation:

If you have a TEM image of an interface, a surface, or a nanoparticle, you might be interested in the atomic structure of the object you are observing.

This software may help you to generate an atomic model by superimposing whatever you create on top of the image you already have.

### Implementation:

This code is intended to be easy to use, but certainly does not fulfill all of your dreams of what the ideal software for such a purpose should be able to do.

For images, qmb can read .img, .dm3, .tif, .jpg, and a few more common image formats. In the case of .dm3 and .img qmb will also automatically ready the pixel size in A.

For atomic structures qmb reads .cfg format and can write .cfg as well as .xyz files.



### Step 1: Load a HRTEM image





# **Stem** Step 2: Adjust image (rotation, offset, scale...)





# Step 3: Outline the area covered by Grain 1



- 1. Press 'Define Boundaries'
- 2. Use left mouse button to define vertices of polygonal outline of the grain
- 3. Close polygon by clicking the right mouse button (this will connect the start and end points of the outline)



# Step 4: Load .cfg file of Grain 1's structure



- 1. Press 'Load Structure' and select the .cfg file you want to fill this grain with (e.g. use Si.cfg from the qmb\_Example folder)
- 2. You may use the toolbar buttons to zoom in/out and pan







- 1. Press 'Zone Axis'
- Define h,k, and I of your desired zone axis (this defines the required tilt angles) You may also change these angles to deviate from exact zone axis
- 3. Press 'Update' in the 'Create Model' box to display the rotated structure of this grain.



## Step 6: Define z-rotation and offsets



- 1. The first 2 tilt parameters define the zone axis, and the 3<sup>rd</sup> the rotation of this zone
- 2. Use x- and y- offsets to shift atomic columns on top of the image features you think they correspond to (ideal are: NCSI contrast or phase of exit wave)
- 3. Define the z-range of the current grain (here from thickness 0 .. 10 nm)
- 4. Atom Size changes size of atom-representing dots (zoom-independent).

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	Background Image Island (582 × 519 pixels)-
	Load Image Redraw
	Pixel Size (A): 0.165 0.165
	Box Size (A): 94 84
	Rotation (deg): 2
	Offset (A): 1.5 1.5
	Contrast: 0 100
	Create Model
55	Grain: 1 Define Boundaries
	Si.cfg Load Stanton Upda
	Tilt (*): 90.000 -45.000 54.1
	Offset A); 13 0.9 0
	Z-range (A): 0 100 Zone A
	Atom Size 25
45	Model Tuning
	Load Model Update
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	A
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	Delete Column Forget Select
35	
	Save Model Export XY2





- 1. Change the grain index to '2'
- 2. Press 'Define Boundaries' and outline the next grain



# Step 7: Align atomic columns with image



Repeat steps 4 through 6 for grain 2

- Note: the size of the atom-representing dots is independent of the zoom on the image
- If all the grains are defined, press 'Update' in the 'Model Tuning' box.





## Step 8: Fine-Tuning the Model



- 1. Draw a box around the atomic columns you want to modify (if the rubberbox does not appear, press 'Update' in the 'Model Tuning' box)
- 2. You can now either delete these columns or shift them by the amount defined between the arrow keys (in Å) in any of those 4 directions.







Finally, you can save the model in either .cfg format (for continued cutting in 3D space using gbmaker or for continuing with (qstem) TEM image simulations)

### or

You can export the atomic structure in .xyz format (for display and further processing in other tools\*)

Save Model

Export XYZ

\* e.g. Vesta (http://www.geocities.jp/kmo\_mma/crystal/en/vesta.html)



## XYZ Model loaded into Vesta







## Model loaded into qstem



gstem	
moder. https://www.energie.org/	Simulate images from wave function
	Probe arrayArray size:400X400pixelsResolution: $0.239438$ X $0.213607$ AWindow size:95.775X85.4426AScattering angle:34.9X39.1mradSlicingImage: Slice per sub-slabs:1Image: Slice per sub-slabs:1Number of horizontal model sub-slabs:20(Total: 100)Slice thickness:4.9998ACenter slicesPeriodic X,YPeriodic ZPotential offset:X:0Y:0Microscope parametersHigh voltage:200kV (wavelength = 2.51pm)Defocus:-60nmScherzerAstigmatism:0nmangle:0
0  10  20  30  40  50  60  70  80  90    Load Model  Update View  3D  Z size  View from    Model Properties  size  5  C Unit cell  © top    Model Properties  size  5  C Slab  C front    Unit cells:  Nx:  1  Ny:  1  Nz:  1  C Box  © Ncells    Sample tilt:  X:  0  Y:  0  Z:  0  © deg  C rad	Spherical Aberr. C3:  1.0  mm    Temperature:  300  K, TDS runs:  30  IV TDS    Cc:  1.0  mm,  dE:  0.5  eV    Convergence angle:  15  mrad    Beam tilt:  X:  0  deg,  Y:  0  T tilt back    Brightness (A/cm2sr):  5  x10 <sup>8</sup> Dwell time:  1  µs    Detectors:



### qstem 'Model Properties'



### Get an idea of what the simulated image might look like ...



TVIE T TOT INTElligent Systems

## **STEM**Front view: 10 nm thick Si + 8 nm thick particle



90  Probe array    70  Probe array    90  Probe array </th <th></th> <th>Simulate images from wave function</th>		Simulate images from wave function
80  Array size:  512  X  512  pixels    70  Array size:  512  X  512  pixels    70  Array size:  512  X  512  pixels    60  Array size:  55  X  85  A    60  Array size:  55  X  85  A    60  Soldering angle:  39.5  X  39.5  mrad    60  Array size:  05  X  85  A    60  Soldering angle:  39.5  X  39.5  mrad    60  Soldering angle:  39.5  X  39.5  mrad    70  Contrastices  Periodic X,Y  Periodic X,Y  Periodic Z    90  10  20  30  Array size:  30  KV (wavelength = 1.97pm)    910  20  30  Contracted  Contracted  Contracted  Contracted    10  Contracted  Contracted  Contracted  Contracted  Contracted  Contracted  Contracted    10  Contracted <th>90</th> <th>Prohe array</th>	90	Prohe array
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10		Astignatism:
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Box:    ax:    85    by:    85    cz:    99.8477    I**    Box    C Ncells      Sample tilt:    X:    0    Y:    0    Z:    0    I**    Detectors:    Number:    1    +    Inner angle:    70    Outer angle:    200    mrad		Brightness (A/cm2sr): 5 x10 <sup>o</sup> Dwell time: 1 <sup>µs</sup>
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### Simulate Images



